



Docket No.: 294901US41PCT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

ATTORNEYS AT LAW

RE: Application Serial No.: 10/589,272
Applicants: Kiyotaka ISHIBASHI, et al.
Filing Date: June 14, 2007
For: PLASMA PROCESSING APPARATUS AND PLASMA
PROCESSING METHOD
Group Art Unit: 1716
Examiner: DHINGRA, RAKESH K.

Commissioner:

Attached hereto for filing are the following papers:

STATEMENT OF INTERVIEW SUBSTANCE UNDER M.P.E.P. § 713.04

Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of **\$0.00** to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. **15-0030**. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, L.L.P.


Philippe J.C. Signore, Ph.D.

Registration No. 43,922

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)
(OSMMN 02/12)

Richard L. Allen
Registration No. 64,830